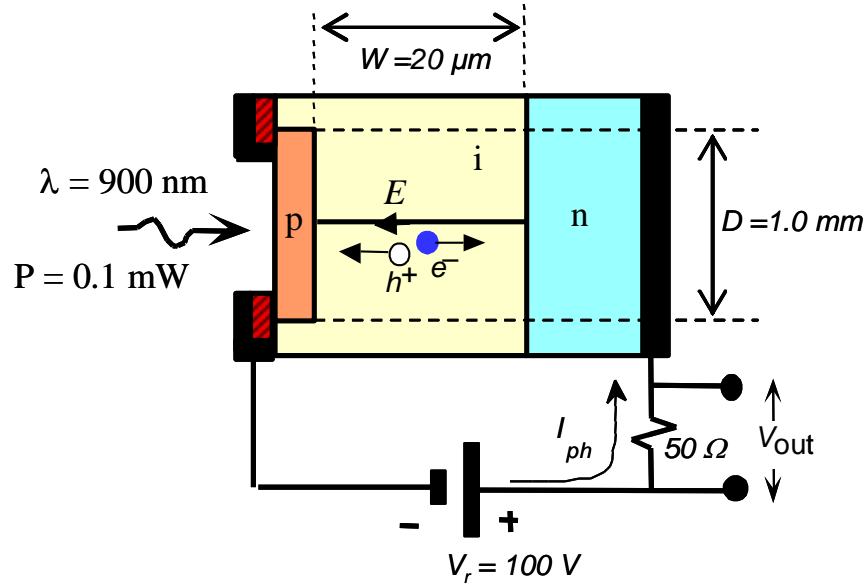


OPTI 500 D, HOMEWORK #2

Solutions



- The p-i-n photodiode shown above is fabricated from n-type, p-type and i-type (undoped) silicon. The front surface has been anti-reflection coated so that all incident light enters the semiconductor. The absorption coefficient for silicon is approximately 300 cm^{-1} for light with a wavelength of 900 nm. The n-type layer is 0.1 microns thick – sufficiently thin so that light absorption is negligible for this layer. Calculate the quantum efficiency for the photodiode at 900 nm, assuming that any light that passes through the i-layer into the p-layer is lost and does not contribute to photocurrent.

The fraction of light that is absorbed in the i-layer is $1 - e^{-300 \times .002} = 0.45$, all other light is lost. The quantum efficiency is $\eta = 0.45$.

- Find the responsivity for the photodiode at 900 nm in units of Amps/Watt. (Planck's constant is $h = 6.6261 \times 10^{-34} \text{ J s}$).

$$R = \eta e / h\nu = \eta e \lambda / hc = 0.45 (1.6 \times 10^{-19}) (.9 \times 10^6) / (6.6261 \times 10^{-34}) (3.0 \times 10^8) = 0.33 \text{ Amps/Watt}$$

3. Find the voltage across the external 50-ohm load if the optical power on the photodiode is 0.1 mW at a wavelength of 900 nm.

The current in the circuit is $RP = 0.33 \times 0.1 \text{ mW} = .033 \text{ mA}$. The voltage is $.033 \text{ mA} \times 50 \text{ ohm} = \boxed{1.65 \text{ mV}}$.

4. The photodiode has a reverse bias of 100 volts that appears entirely across the undoped i-layer of width 20 microns. Find the transit time for an electron, and for a hole, across the entire 20-micron length of the i-layer, using the drift velocity curves below.

The electric field in the i-layer is $E = V/d = 100/20 \times 10^{-6} = 5 \times 10^6 \text{ V/m}$. The corresponding drift velocities are 10^5 m/s for electrons and $7 \times 10^4 \text{ m/s}$ for holes. The corresponding transit times are $20 \times 10^{-6} / 10^5 = \boxed{0.20 \text{ nanoseconds}}$ for electrons and $20 \times 10^{-6} / 7 \times 10^4 = \boxed{0.29 \text{ nanoseconds}}$ for holes.

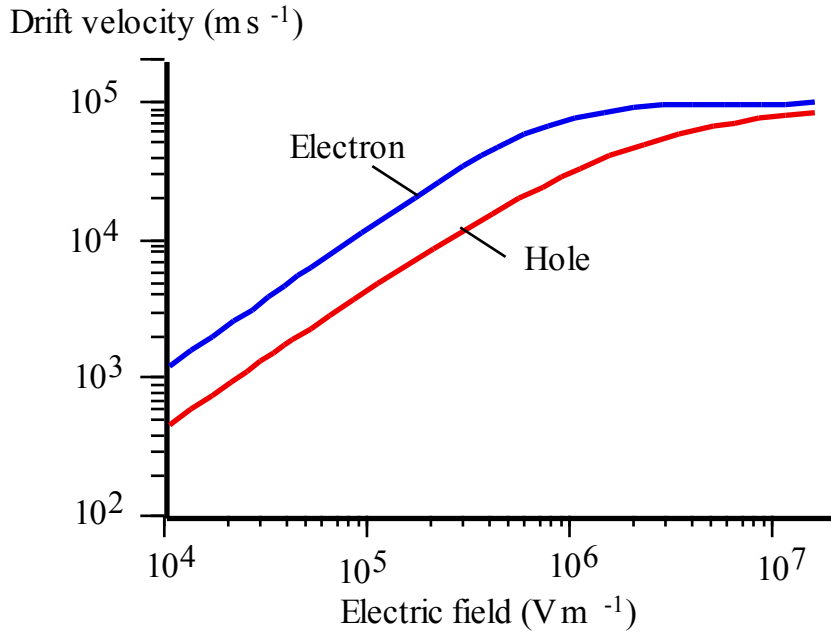
5. The photodiode has a diameter of 1.0-mm.
- Find its capacitance.

$$C = Ak\epsilon_0/w = \pi(.05)^2(11.9)(8.8542 \times 10^{-14})/20 \times 10^{-4} = \boxed{4.14 \text{ picofarad}}$$

For this calculation, use a simple model for the photodiode. Treat the p-i-n structure as if it were equivalent to a parallel metal plate capacitor, with the plates separated by 20 microns and the gap between the plates filled with silicon, a material that has a dielectric constant of 11.9. Parallel plates have a capacitance $Ak\epsilon_0/w$, where A is area of the plates, k is the dielectric constant of the material between the plates, $\epsilon_0 = 8.8542 \times 10^{-14} \text{ F/cm}$ is the permittivity of free space, and w is the plate separation.

- Neglecting any “parasitic” resistance or capacitance, find the RC time constant for the photodiode circuit.

$$RC = 50 \times 4.14 \times 10^{-12} = \boxed{0.21 \text{ nanoseconds}}$$



Drift velocity vs. electric field for holes and electrons in Si.

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